Appl. No. 10/722,226, Amdt. Dtd. October 2, 2006 Reply to Examiner's Office Action of May 2, 2006 & Communication of Sept. 20, 2006

In the Claims:

Claim 1 (currently amended): A multilayer chip carrier, comprising:

a layer of dielectric material having a plurality of signal pads formed thereon in a pattern of signal pads related to a pattern of signal pads within <u>a</u> the footprint of at least one chip to be carried on said chip carrier, said plurality of signal pads including a first set of signal pads near the edge of said chip footprint each having a conductive line connected thereto extending beyond the edge of said chip footprint and a second set of signal pads each having a conductive line connected thereto extending to connect to respective signal pads positioned nearer the said edge of said chip footprint.

Claim 2 (original): The multilayer chip carrier as set forth in Claim 1 wherein at least some of said signal pads on said dielectric layer nearer the said edge of said chip footprint have a conductive via connected thereto that form a set of conductive vias that extend through said layer of dielectric material to the opposing surface thereof.

Claim 3 (original): The multilayer chip carrier as set forth in Claim 2 including a further layer of dielectric material beneath said layer of dielectric material having signal pads thereon with respective ones of said signal pads connected to respective ones of said conductive vias of said set of conductive vias.

Claim 4 (original): The multilayer chip carrier as set forth in Claim 3 wherein at least some of said signal pads on said further layer of dielectric material each have a conductive line connected thereto extending to connect to respective further signal pads nearer the edge of said chip footprint.

Claim 5 (currently amended): The multilayer chip carrier as set forth in Claim 4 wherein at least some of said further signal pads nearer the edge of said chip footprint have conductive vias connected thereto that extend through said further layer of dielectric material to connect to signal pads on another layer of dielectric material with END920030089US1

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Appl. No. 10/722,226, Amdt. Dtd. October 2, 2006 Reply to Examiner's Office Action of May 2, 2006 & Communication of Sept. 20, 2006 said signal pads on said another layer of dielectric material having conductive lines connected thereto extending beyond the edge of said chip footprint.

Claim 6 (original): The multilayer chip carrier as set forth in Claim 5 wherein said plurality of signal pads are arranged adjacent a plurality of power distribution busses.

Claim 7 (original): The multilayer chip carrier as set forth in Claim 6 wherein power PTHs are connected to said power distribution busses in the region of said signal pads.

Claim 8 (original): The multilayer chip carrier as set forth in Claim 1 including a chip attached thereto.

Claim 9 (original): The multilayer chip carrier as set forth in Claim 8 wherein said multilayer chip carrier is electrically attached to a printed wiring board.

Claim 10 (withdrawn): A multilayer chip carrier substrate, comprising:
one layer of dielectric material having positioned thereon a plurality of signal pads
some of which form a first set of signal pads having conductive lines connected thereto
extending beyond the edge of the footprint of the chip to be attached thereto and some of
which form a second set of signal pads having conductive lines connected thereto
extending toward the edge of said footprint to connect to a third set of signal pads, said
third set of signal pads having conductive vias connected thereto which are respectively
connected to a corresponding set of said signal pads on another layer of dielectric
material.

Claim 11 (withdrawn): The multilayer chip carrier substrate set forth in Claim 10 wherein at least some of said signal pads of said corresponding set of signal pads on said another layer of dielectric material have conductive lines connected thereto that extend toward the edge of said footprint to respectively connect to a fourth set of signal pads.

Claim 12 (withdrawn): The multilayer chip carrier substrate as set forth in Claim 11 wherein at least some of said signal pads of said fourth set of signal pads on said another layer are connected to conductive vias which vias connect to a corresponding set of signal pads on a further layer of dielectric material.

Claim 13 (withdrawn): The multilayer chip carrier as set forth in Claim 12 wherein at least some of said signal pads of said set of signal pads on said further layer of dielectric material have conductive lines connected thereto extending beyond the edge of said footprint of said chip.

Claim 14 (withdrawn): The multilayer chip carrier as set forth in Claim 10 wherein said signal pads of said plurality of signal pads are arranged adjacent a plurality of power distribution busses.

Claim 15 (withdrawn): The multilayer chip carrier as set forth in Claim 14 wherein power PTHs are connected to said power distribution busses on said further layer of dielectric material in the region of said first, second and third sets of signal pads.

Claim 16 (withdrawn): The multilayer chip carrier as set forth in Claim 15 wherein said first and second set of signal pads are generally arranged in columns and rows and said power distributions busses are arranged between at least some of said columns and rows of signal pads.

Claim 17 (withdrawn): The multilayer chip carrier as set forth in Claim 10 including a chip having an array of contacts electrically connected to pads on said chip carrier by solder connections at least some of which provide signals to said plurality of signal pads.

Claim 18 (withdrawn): The multilayer chip carrier as set forth in Claim 17 wherein said chip carrier is electrically connected to a printed wiring board.

Claim 19 (currently amended): A multilayer chip carrier, comprising:

a first layer of dielectric material having a plurality of signal pads formed thereon arranged in a pattern of signal pads related to signal pads within the a footprint of at least one chip to be carried by said chip carrier, said plurality of signal pads including a first set of signal pads near the edge of said chip footprint with each pad of said first set of signal pads having a conductive line lines connected thereto extending beyond the edge of said chip footprint and a second set of signal pads with each pad of said second set of signal pads having a conductive line connected thereto extending to connect to respective signal pads of another set of signal pads positioned closer to the edge of said chip footprint with said another set of signal pads positioned closer to the edge of said chip footprint each having a conductive vias via connected thereto extending through said first layer of dielectric material to form a set of conductive vias in said first layer of dielectric material;

a second layer of dielectric material having a <u>first</u> set of signal pads <u>formed</u> arranged thereon <u>with respective ones of said first set of signal pads arranged to connect respectively connected</u> to <u>respective ones of</u> said <u>set of</u> conductive vias extending through said first layer of dielectric material and <u>with each pad of said first set of signal pads</u> having <u>respective a</u> conductive <u>lines line</u> connected thereto extending to <u>connect to respective respectively connect to further</u> signal pads <u>of a second set of signal pads on said second layer of dielectric material</u> positioned closer to the edge of said chip footprint, <u>each pad of</u> said <u>second set of further</u> signal pads having <u>a</u> conductive <u>vias via</u> connected thereto extending through said second layer of dielectric material <u>to form a set of conductive vias in said second layer of dielectric material</u>; and

a third layer of dielectric material having a set of signal pads <u>formed arranged</u> thereon <u>respectively with respective ones of said set of signal pads of said third layer of dielectric material arranged to connected to <u>respective ones of the</u> said <u>set of conductive</u> vias extending through said second layer of dielectric material and <u>with each pad of said</u></u>

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set of pads on said third layer of dielectric material having a conductive line lines
respectively connected thereto extending beyond the edge of said chip footprint.

Claim 20 (original): The multilayer chip carrier as set forth in Claim 19 including at least one chip having a pattern of electrical contacts corresponding to said pattern of signal pads electrically connected thereto.

Claim 21 (original): The multilayer chip carrier as set forth in Claim 20 wherein said chip carrier is electrically attached to a printed wiring board.

Claim 22 (withdrawn): A method of fanout redistribution of signal pads on a multilayer chip carrier, comprising:

providing a layer of dielectric material having a plurality of signal pads formed thereon in a pattern of signal pads within the footprint of at least one chip to be carried therein;

providing conductive lines connected to a first set of signal pads of said plurality of signal pads near the edge of said chip footprint extending beyond the edge of said chip footprint to allow signals from said first set of signal pads to escape said chip footprint; and

moving a second set of signal pads of said plurality of signal pads closer to the edge the edge of said chip footprint.

Claim 23 (withdrawn): The method as set forth in Claim 22 including the step of providing at least some of said signal pads moved closer to the edge of said chip footprint with connections to signal pads on another layer of dielectric material below said layer of dielectric material.

Claim 24 (withdrawn): The method as set forth in Claim 23 including the step of moving at least some of said signal pads on said another layer of dielectric material closer to the edge of said chip footprint.

Claim 25 (withdrawn): The method as set forth in Claim 24 including the step of providing at least some of said signal pads on said another layer of dielectric material moved closer to the edge of said chip footprint with connections to signal pads on a further layer of dielectric material below said another layer of dielectric material.

Claim 26 (withdrawn): The method as set forth in Claim 25 including the step of providing conductive lines connected to at least some of the said signal pads on said further layer of dielectric material that extend beyond the edge of said chip footprint to allow signals from said signal pads on said further layer to escape said chip footprint.

Claim 27 (withdrawn): The method as set forth in Claim 26 wherein said plurality of signal pads are arranged adjacent a plurality of power distribution busses.

Claim 28 (withdrawn): The method as set forth in Claim 27 wherein PTHs are connected to said power distribution busses in the region of said moved signal pads.

Claim 29 (withdrawn): The method as set forth in Claim 28 wherein at least one chip is attached to said multilayer chip carrier.

Çlaim 30 (withdrawn): The method as set forth in Claim 29 wherein said multilayer chip carrier is attached to a printed wiring board.